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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

MIZUHARA et al.

Serial No.: 09/037,674

Filed: March 9, 1998

Atty. File No.: 2933SE-11-CIP-2

For: "SEMICONDUCTOR DEVICES
PASSIVATION FILM"

) Group Art Unit: 2814

) Examiner:

) SUPPLEMENTAL INFORMATION
) DISCLOSURE STATEMENT

CERTIFICATE OF MAILING

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING
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DC 20231 ON November 11, 1999.

SHERIDAN ROSS P.C.

BY: *Aimee Thuerk*

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Pursuant to the duty of disclosure under 37 CFR § 1.56 and 37 CFR §§ 1.97-1.98, Applicants hereby provide a copy of each of the documents identified on the enclosed PTO Form 1449, although Applicants do not admit that any of such documents, alone or in any combination, is considered to be material to patentability as defined in 37 CFR § 1.56(b). Moreover, the inclusion of these documents is not to be construed as an admission by Applicants that each such document is prior art as to the above-identified patent application.

Further pursuant to the duty of disclosure, an English language abstract of each of the identified documents that is not in the English language is submitted as a concise explanation of the relevance of each such document.

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Respectfully submitted,

NOV 19 1999

SHERIDAN ROSS P.C.

TECHNOLOGY CENTER 2800

Date: November 11, 1999

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